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CONFIRMATION NO. 1134

SERIAL NUMBE 10/524,525	FILING OR 371(c) DATE 08/18/2005 RULE	CLASS 216	GROUP AR'	PUP ART UNIT 1763		ATTORNEY DOCKET NO. BEET-09	
## APPLICANTS Martin Hausner, Wiesbaden, GERMANY; *** CONTINUING DATA ******************* This application is a 371 of PCT/EP03/09052 08/14/2003 *** FOREIGN APPLICATIONS ************************************							
met				TOTAL CLAIMS 3 23		INDEPENDENT CLAIMS 2	
26875 TITLE Method for selectively removing material from the surface of a substrate, masking material for a wafer, and wafer with masking material							
FILING FEE FI	EES: Authority has been given in Paper o to charge/credit DEPOSIT ACCOUNT o for following:			All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit			